67,200-1121 2002-1020/1093

## **DECLARATION FOR PATENT APPLICATION**

As a below-named inventor, We hereby declare that:

My residence, post office address and citizenship are as stated below next to my name,

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled

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the specification	n of which	wa	attached hereto.  Is filed on as ion Serial No. Is amended on as iable)			
			d and understand the contamended by any amendednents			
I acknowledge application in a attached.	the duty to ecordance w	disclose i ith Title 3	nformation which is materi 7, Code of Federal Regulation	al to the exam ons, §1.56, a co	ination of this opy of which is	
application(s) for	or patent or tion(s) for p	inventor's atent on ir	s under Title 35, United Sta certificate listed below and l wentor's certificate having a d:	nave also identi	fied below any	
Prior Foreign Application(s)				Priority Claimed		
Number	Coun	try	Day/Month/Year	(Yes)	(No)	
Number	Coun	try	Day/Month/Year	(Yes)	(No)	
Number	Coun	ŧry	Day/Month/Year	(Yes)	(No)	